



[10191/1728]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors : GROSSE et al. Confirmation No.: 9967
Serial No. : 09/831,722
Filed : September 6, 2001
For : DEVICE AND METHOD FOR PRODUCING
A LOCAL PLASMA THROUGH
MICROSTRUCTURE ELECTRODE
DISCHARGES USING MICROWAVES

Examiner : E. Fuller
Art Unit : 1762
Customer No. : 26646

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Date 11/2/08 Atty's Reg. # 41,172

Atty's Signature

[Signature]
**DERVIS MAGISTRE
KENYON & KENYON**

AMENDMENT

SIR:

In response to the Office Action of May 31, 2005, kindly amend the above-captioned application as follows:

Amendments to the Specification do not appear this paper.

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Amendments to the Drawings do not appear this paper.

Remarks begin on page 7 of this paper